



In re Application of:

Yasunori INOUE et al.

Group Art Unit: 1763

Serial No.: 08/921,250

Examiner: George A. Goudreau

Filed: August 29, 1997

P.T.O. Confirmation No.: 9314

For:

FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE

LIQUID USED THEREIN

REQUEST FOR CORRECTION OF PATENT OFFICE RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

August 24, 2004

Sir:

Applicants received a Notice of Allowability dated July 26, 2004. The allowed claims should read "3-9, 11-14, 16, 17, 19, 20, 22-27 and 31" since claims 10 and 18 were canceled in the Amendment filed September 5, 2002. Correction is respectfully requested.

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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